



28578

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Masaya OGURA et al.) Examiner: H. Nguyen
Application No.: 09/811,419) Group Art Unit: 2851
Filed: March 20, 2001)
For: EXPOSURE APPARATUS, METHOD OF) October 17, 2002
MANUFACTURING SEMICONDUCTOR)
DEVICES AND PLANT THEREFOR)

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Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below:

| CLAIMS AS AMENDED | | | | | | |
|---|---|-------|---------------------------------------|------------------|----------------|-------------------|
| | CLAIMS REMAINING AFTER AMENDMENT | | HIGHEST NO. PREVIOUSLY PAID FOR | PRESENT EXTRA | RATE | ADDITIONAL FEE |
| TOTAL CLAIMS | 15 | MINUS | 20 | = 0 | x \$9 \$18 | \$0.00 |
| INDEP. CLAIMS | 3 | MINUS | 3 | = 0 | x \$42 \$84 | \$ 0.00 |
| Fee for Multiple Dependent claims \$140/\$280 | | | | | | — |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT | | | | | | \$0.00 |

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

☐ A check in the amount of \$_____ is enclosed including the additional claims fee.

☐ Charge \$____ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.

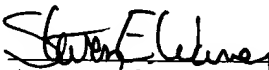
☒ Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.

☒ A check in the amount of \$400.00 to cover the fee for a two month extension is enclosed.

☐ A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.

☒ Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO

30 Rockefeller Plaza

New York, New York 10112-3801

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10-28-02

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| Filed: March 20, 2001 |) | |
| For: EXPOSURE APPARATUS, METHOD OF |) | October 17, 2002 |
| MANUFACTURING SEMICONDUCTOR: |) | |
| DEVICES AND PLANT THEREFOR |) | |

The Commissioner for Patents
Washington, D.C. 20231

AMENDMENT WITH PETITION FOR EXTENSION OF TIME

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated May 17, 2002, for two months from August 17, 2002, to October 17, 2002. A check in the amount of \$400.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, or credit any overpayment, to Deposit Account 06-1205.

In response to the Official Action dated May 17, 2002, please amend the above-identified application as follows:

10/21/2002 AOSMAN1 00000071 09811419

01 FC:1252

400.00 DP